



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Mitsunori TOYODA

Group Art Unit: 2851

Application No.: 10/521,590

Examiner: H. NGUYEN

Filed: January 18, 2005

Docket No.: 122397

For: ILLUMINATION OPTICAL DEVICE, PHOTOLITHOGRAPHY MACHINE, AND
EXPOSURE METHOD

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the April 25, 2006 Restriction Requirement, Applicant hereby elects
Group I, claims 13-25. The election is made with traverse.

Applicant respectfully submits that the subject matter of all pending claims is
sufficiently related that a thorough search for the subject matter of any one Group of claims
would encompass a search for the subject matter of the remaining claims. Thus, Applicant
respectfully submits that the search and examination of the entire application could be made
without serious burden. See MPEP §803 in which it is stated that "if the search and
examination of the entire application can be made without serious burden, the examiner must
examine it on the merits even though it includes claims to independent or distinct inventions."
Applicant respectfully submits that this policy should apply in the present application to avoid
unnecessary delay and expense to Applicant and duplicative examination by the Patent
Office.

The Examiner also is requested to consider the information submitted with the Information Disclosure Statement filed with this application on January 18, 2005.

Respectfully submitted,



Mario A. Costantino
Registration No. 33,565

MAC/ccs

Date: May 19, 2006

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461